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FROM: Elizabeth Anderson

DATE: August 26, 2005

APPLN. No.: 10/733,729

OUR REF.: 4717-9200

Please Deliver as Soon as Possible To:

RECIPIENT	COMPANY	FAX NO.	PHONE NO.
Examiner David Nhu	U.S. Patent and Trademark Office	571-273-1792	571-272-1792

Total number of pages including this page: 3

## COMMENTS

In re Application of Walter Schwarzenbach et al.  
Application No.: 10/733,729  
Filed: December 12, 2003  
Title: Method of Making Cavities in a Semiconductor

In accordance with our telephone conversation of this afternoon, attached is a courtesy copy of the sheet of replacement drawings including Figs. 3A, 3B, 3C and 5, which will be hand-filed with the USPTO today.

Elizabeth Anderson  
Senior Paralegal

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: W. SCHWARZENBACH et al. Confirmation No.: 9739  
Application No.: 10/733,729 Group Art Unit: 2818  
Filing Date: December 12, 2003 Examiner: David Nhu  
For: METHOD OF MAKING CAVITIES IN A Semiconductor Attorney Docket No.: 4717-9200  
SEMICONDUCTOR

**SUBMISSION OF FORMAL DRAWINGS**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450




Sir:

In response to the Notice of Allowability mailed August 11, 2005, submitted herewith is a copy of one (1) sheet of replacement formal drawings including Figs. 3A, 3B, 3C and 5. Applicants respectfully request that the attached sheet of replacement drawings be substituted for the annotated drawings filed on July 27, 2005 and approved by the Examiner on August 11, 2005.

No fee is believed to be due for this submission. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

8/26/05  
\_\_\_\_\_  
Date

  
Jeffrey A. Wolfson (Reg. No. 42,234)

**WINSTON & STRAWN LLP**  
Customer No. 28765

202-282-5770

Application No.: 10/733,729; Filed: December 12, 2003  
Conf. No.: 9739; Atty. Dkt. No.: 4717-9200  
Replacement Sheet

2/3

*DN  
approved  
8/26/05*

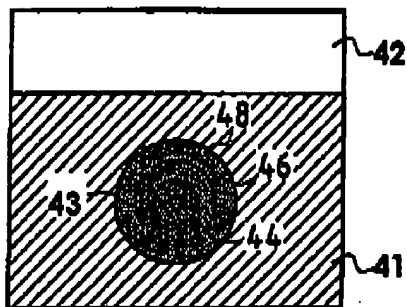


FIG. 3A

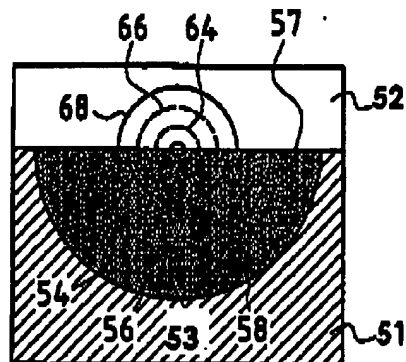


FIG. 3B

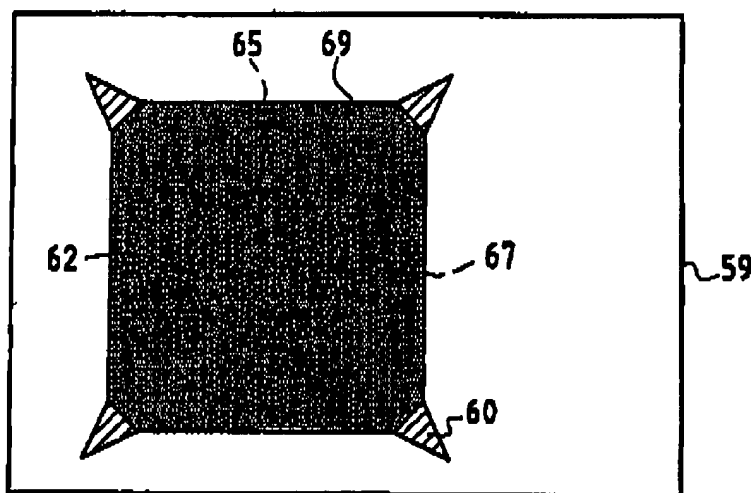


FIG. 3C

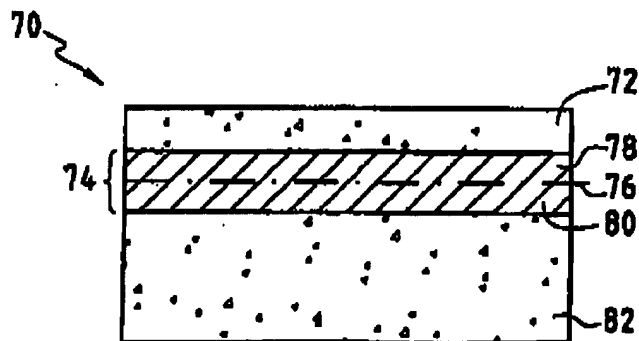


FIG. 5